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PATENT
Attorney Docket No. 0553-0255

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2822
#141C
9/23/03

In re application of:)
)
Yamazaki et al.)
)
Serial No: 09/841,537 ✓)
)
Filed: April 24, 2001)
)
Art Unit: 2822)
)
Examiner: M. Prenty)
)
For: A SEMICONDUCTOR DEVICE)
And Method Of Fabricating))
Thereof)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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Date September 9, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C

Dear Sir:

In response to the Office Action dated June 10, 2003,
please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 1, 10, 19 and 27 as follows.

CI
1. (currently amended) A semiconductor device comprising:
a thin film transistor comprising a semiconductor layer
over a substrate and a gate electrode with an insulating film
interposed therebetween;

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